



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Inventor(s) : Tatsuo ENAMI *et al.*  
Serial Number : 09/518,639  
Filed : March 3, 2000  
For : ArF EXCIMER LASER DEVICE SCANNING TYPE  
EXPOSURE DEVICE AND ULTRAVIOLET LASER  
DEVICE  
Examiner : Dung T. Nguyen  
Group Art Unit : 2828

**RESPONSE AFTER FINAL UNDER 37 C.F.R. § 1.116**

Dear Sir:

June 30, 2004

The following amendments and remarks are submitted in response to the Official action mailed March 1, 2004. The Official action set forth a three-month period for response, and a petition for one-month extension of time is attached hereto, making this response due on or before July 1, 2004.

Please amend the above-identified application as set forth on the following pages.